

We are so pleased to announce the recipients of AM-FPD '14 Award.

They will be presented the award in the Opening Session of AM-FPD '15 on July 1, 2015.

AM-FPD '14 Best Paper Award

6-3 **Effect of Aluminum and Indium Composition on the Bias-Illumination-Stress Stability of Solution-Processed Transparent Al-In-Zn-O Thin-Film Transistors**

Min-Ji Park, Jun-Yong Bak, Jeong-Seon Choi, Sung-Min Yoon, *Kyung Hee University, Korea*

AM-FPD '14 Poster Award

P-19 **Effects of Etch Stop Layer Deposition Conditions on Stress Stabilities in Amorphous In-Ga-Zn-O Thin Film Transistors**

Aya Hino, Hiroaki Tao, Yasuyuki Takanashi, Mototaka Ochi, Hiroshi Goto, Kazushi Hayashi, Toshihiro Kugimiya, *Kobe Steel, Ltd., Japan*

AM-FPD '14 Student Paper Award

Yana Mulyana, Nara Institute of Science and Technology, Japan

3-3 Oxidation of Graphene Film by Non-Thermal Treatment for New Sensing Devices

AMFPD '14-ECS Japan Section Young Researcher Award

Jong-Hyeok Park^{1,2}, ¹*Kyushu University, Japan*, ²*JSPS Research Fellow, Japan*

3-4 Formation of Quasi-Single-Crystal Ge on Plastic by Nucleation-Controlled Au-Induced Layer-Exchange Growth for Flexible Electronics